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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Meikei Leong et al.

Examiner: Erdem, Fazli

Serial No: 10/696,634

Art Unit: 2826

Filed: October 29, 2003

Docket: YOR920030394US1 (16963)

For: CMOS ON HYBRID SUBSTRATE WITH
DIFFERENT CRYSTAL ORIENTATIONS
USING SILICON-TO SILICON DIRECT WAFER
BONDING

Dated: September 9, 2004

Confirmation No.: 5489

Commissioner for Patents
United States Patent Office
Alexandria, VA 23313-1450

RESPONSE UNDER 37 C.F.R. §1.111 AND 1.143

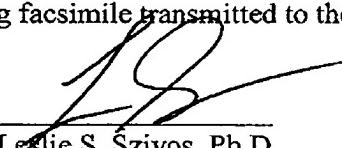
Sir:

In response to the Office Action dated August 25, 2004, applicants provisionally elect, without traverse, the subject matter of Group I, i.e., Claims 1-9 and 24-35 for continued prosecution in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: September 9, 2004



Leslie S. Szivos, Ph.D.